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- L36:(66778) 30 near 6 35
- L37:(42) 32 with 38
- L38:(11) 37 with 3
- L39:(31) 37 with 1
- L40:(11) 37 same 3
- L41:(31) 37 same 1
- L42:(11960) 1 near 9 4
- L43:(47) 142 near 9 22
- L44:(38) 104061 gate source
- L45:(44) 75221 5 19 44
- L46:(6788) 45 near 9 1
- L47:(46) 43 same 48
- L48:(38) 118811 l@ad@pdj >"20030618"
- L49:(31) 47 not 48
- L50:(31) 49 and 1
- L51:(9775) 42 not 48
- L52:(394) 51 same 5
- L53:(394) 52 same 4
- L54:(229) 52 same 44
- L55:(213) 59 strained
- L56:(13) 55 adj 1
- L57:(98) 55 near 41
- L58:(10) 54 and 57
- L59:(4) 51 and 57
- L60:(4) 59 and 1

Selected

58 and 1

May 2005

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U	Document Issue P	Title	Current Current I	Retired S	C	E	Image	DoP
1	<input type="checkbox"/> Todd, Mich US 200201 2002	2 Deposition Over Ribbed Substrates	438/76 257/E21.10	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 200201
2	<input type="checkbox"/> Notsu, Kazu US 2002014 2002	3 Semiconductor member manufacturing method	438/45 257/E21.57	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 200201
3	<input checked="" type="checkbox"/> KAYA, TATSU JP 0215389 1990	3 LAMINATED SINGLE CRYSTAL SUBSTRATE	17/789:	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	JP 021538
4	<input type="checkbox"/> BOHARA, R C US 4777826 1988	12 Twin film strain gauge system - has sim		<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 477782

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